

## **ECE 8443 – PATTERN RECOGNITION**

### **COURSE OUTLINE:**

#### **I. INTRODUCTION TO PATTERN RECOGNITION**

- A. Machine Perception
- B. Pattern Recognition Systems
- C. Design Cycle
- D. Learning Models

#### **II. BAYESIAN and MAXIMUM LIKELIHOOD APPROACHES**

- A. Decision Theory
- B. Bayes Classifiers and Discriminant Functions
- C. Maximum Likelihood Classifiers
- D. Error Rates, Probabilities, and bounds

#### **III. DIMENSIONALITY PROBLEM**

- A. Problem of Dimensionality
- B. PCA and LDA
- C. EM (Expectation-Minimization)
- D. HMM (Hidden Markov Models)

#### **IV. NONPARAMETRIC METHODS**

- A. Parzen Window
- B. Nearest Mean
- C. Nearest Neighbor

#### **V. LINEAR DISCRIMINANT FUNCTIONS**

- A. Linear and Generalized Linear Discriminant Functions
- B. Relaxation Procedures
- C. Separable and Nonseparable Cases

#### **VI. MACHINE LEARNING**

- A. Classifier Superiority
- B. Bias and Variance
- C. Reasampling
- D. Combination and Comparison of Classifiers

#### **VII. UNSUPERVISED CLUSTERING**

- A. Mixture Densities
- B. ML and Bayesian Approaches
- C. Clustering
- D. Criterion Functions for Clustering
- E. Hierarchical Clustering